

41. (Amended) The piezoelectric/electrostrictive film element in Claim

A2 40, wherein the method further comprises a step of drying the piezoelectric/electrostrictive film between g) and h).

Please add the following new claims:

Please add Claims 58-61

A3 58. The piezoelectric/electrostrictive film element in Claim 20, wherein the method further comprises a step of drying said piezoelectric/--electrostrictive film between g) and h).

59. The piezoelectric/electrostrictive film element in Claim 61, wherein said piezoelectric/electrostrictive film is dried at 70-100°C.

60. The piezoelectric/electrostrictive film element in Claim 39, wherein the method further comprises a step of drying the piezoelectric/-electrostrictive film between g) and h).

61. The piezoelectric/electrostrictive film element in Claim 63, wherein said piezoelectric/electrostrictive film is dried at 70-100°C.